

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Ho-Shang LEE et al.		
Title:	Light Emitting System with High Extraction Efficiency		
Application No.:	10/773,943	Filing Date:	February 6, 2004
Examiner:	Johannes P. MONDT	Group Art Unit:	3663
Docket No.:	DICO.049US0	Conf. No.:	7975

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING RCE AND
APPLICANT'S STATEMENT OF INTERVIEW

Sir:

This is in response to the final Office Action dated January 20, 2006, setting a period for response expiring on April 20, 2006. An appropriate request for extension of time accompanies this paper.

Amendments to the Specification begin on page 2 of this paper.

Reasons Presented in the Interview of April 21, 2006 Warranting Favorable Action appears on page 5 of this paper.

Amendments to the Claims begin on page 6 of this paper.

Amendments to the Drawings are being made, as shown on page 12; Annotated and Replacement Drawings are attached hereto.

Remarks begin on page 13 of this paper.